

<b>Notice of References Cited</b>	Application/Control No. 09/924,768	Applicant(s)/Patent Under Reexamination MIKI ET AL.	
	Examiner Andrew C Lee	Art Unit 2664	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,850,531	02-2005	Rao et al.	370/401
	B	US-6,665,718	12-2003	Chuah et al.	709/225
	C	US-6,574,224	06-2003	Brueckheimer et al.	370/395.6
	D	US-6,452,920	09-2002	Comstock, David R.	370/349
	E	US-6,862,622	03-2005	Jorgensen, Jacob W.	709/226
	F	US-6,763,018	07-2004	Puthiyandyil et al.	370/352
	G	US-6,151,628	11-2000	Xu et al.	709/225
	H	US-6,452,920	09-2002	Comstock, David R.	370/349
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.